



Attorney's Docket No.: 07977/093002 / US3164D1

AV/2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani, Art Unit : 2815
et al. Examiner : Eugene Lee
Serial No. : 09/379,702
Filed : August 24, 1999
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICES

Commissioner for Patents
Washington, D.C. 20231

#23/EX
5/14/3
Surles
RECEIVED
APR 23 2003
TC 2800 MAIL ROOM

PETITION FOR ONE-MONTH EXTENSION OF TIME


Pursuant to 37 CFR §1.136, applicant hereby petitions that the period for response to the action dated October 16, 2002, be extended for one month to and including April 16, 2003.

Enclosed is a check for \$110 for the required fee. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 04/16/03

Scott C. Harris
Reg. No. 32,030

Fish & Richardson P.C.
Customer Number: 20985 *  *
4350 La Jolla Village Drive, Suite 500
San Diego, California 92122
Telephone: (858) 678-5070
Facsimile: (858) 678-5099
10269688.doc

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

04/22/2003 BNGUYEN1 00000052 09379702

02 FC:1251

110.00 OP

April 16, 2003
Date of Deposit

Signature

Roxanne Ippolito

Typed or Printed Name of Person Signing
Certificate